



Corrigendum

Sub: Request for Quote for procurement of an epitaxial CVD system for Si, SiGe and Ge Epitaxial CVD Systems

Ref: Advertisement for RFQ (Request for Quote) document for procurement of an epitaxial CVD system along with attachments posted on 9th July.

The following corrigendum is issued in the above matter:

Existing	Modified as
The deadline for submission of proposals is the 26th of July 2018, 5:30 pm Indian Standard Time.	The deadline for submission of proposals is the 3rd of August 2018, 5:30 pm Indian Standard Time.

Any questions or clarifications can be directed to:

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